



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

March 9, 2026

IGI Report Number

LG779632877

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

Measurements

10.68 X 7.90 X 5.38 MM

GRADING RESULTS

Carat Weight

3.89 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG779632877

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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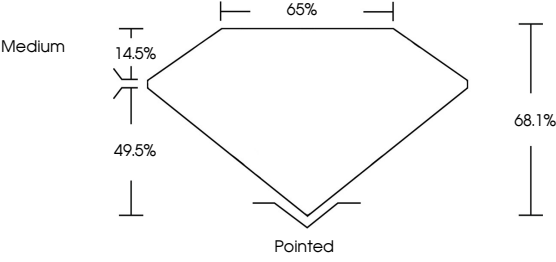
NONE

Inscription(s)

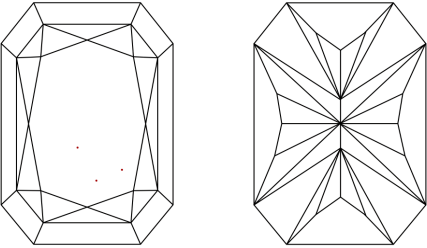
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PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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CUT CORNERED RECT. MODIFIED BRILLIANT

10.68 X 7.90 X 5.38 MM

3.89 CARATS

E

Carat Weight

Color Grade

VVS 2

68.1%

65%

Medium

Depth

Symmetry

Fluorescence

Inscription(s)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG779632877

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

EXCELLENT

EXCELLENT

NONE

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